	Search Notes				
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Application/Control No.	Applicant(s)/Patent under Reexamination	-
10/751,464	KIM ET AL.	
Examiner	Art Unit	
Linh V. Nauven	2819	

SEARCHED			
Class	Subclass	Date	Examiner
341	50,51 52,55 56,95	3/28/2006	LN

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
PGPUB-Tex see pi		3/28/2006	LN

SEARCH NO (INCLUDING SEARC)
	DATE	EXMR
East - searched - See printout	3/26/2006	LN